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	Applicant(s): Mutsumi YANO, et al.	
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U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA	/				
_____	AB					
_____	AC					
_____	AD					

FOREIGN PATENT DOCUMENTS

Document No.	Date	Country	Translation (Yes or No)
<u>AE</u> 5-121275	05/18/93	Japan	Yes-Abstract/Discussed in the specification
<u>AF</u> 11-312628	11/09/99	Japan	Yes-Abstract/Discussed in the specification
_____ AG	/		
_____ AH			
_____ AI			

OTHER DOCUMENTS

<u>AJ</u>	G.E. Thompson et al.; "The Migration of Fluoride Ions in Growing Anodic Oxide Films on Tantalum"; <i>Journal Electrochemical Society</i> ; Vol. 144; No. 2; pp. 418-423, February, 1997.	
_____ AK		
Examiner	<u> </u> Date Considered	6/16/04